



**ELECTRONIC COPY**

LG794604834  
Report verification at igi.org



May 23, 2026

IGI Report Number **LG794604834**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **EMERALD CUT**

Measurements **9.30 X 6.58 X 4.46 MM**

**GRADING RESULTS**

Carat Weight **3.01 CARATS**

Color Grade **F**

Clarity Grade **FLAWLESS**

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**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

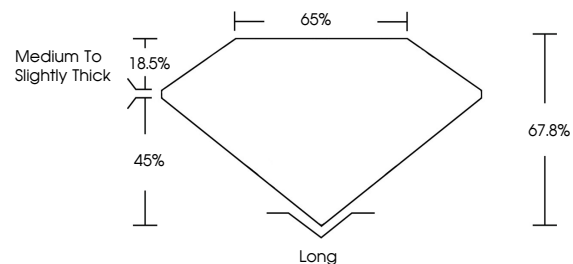
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG794604834**

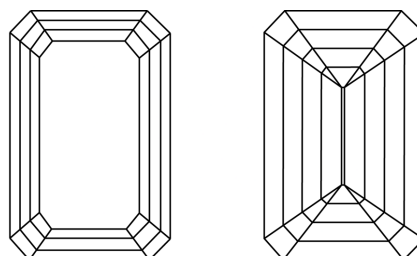
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

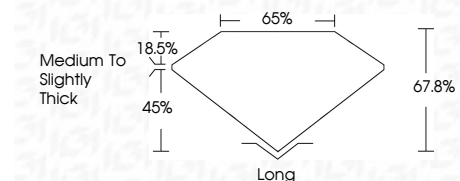
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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**IGI**



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IGI Report No LG794604834  
EMERALD CUT

3.01 CARATS  
Carat Weight  
Color Grade  
Clarity Grade  
Table  
Girdle  
Culet  
Polish  
Symmetry  
Fluorescence  
Inscription(s)

**F**  
**FLAWLESS**  
**67.0%**  
**65%**  
**Medium to Slightly Thick**  
**Long**  
**EXCELLENT**  
**EXCELLENT**  
**NONE**  
**IGI LG794604834**

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